In re Application of:

TOSHIKAZU ONISHI ET XXX 181

Docket No. 03500.013314.2

Application No.: 10/014,131

Examiner: K. Ramsey

Filed: December 13, 2001

Group Art Unit: 2879

For: METHOD FOR MANUFACTURING ELECTRON

EMISSION ELEMENT, ELECTRON SOURCE,

AND IMAGE FORMING APPARATUS

Date: April 20, 2004

THE COMMISSIONER FOR PATENTS P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

Transmitted herewith is a Preliminary Amendment in the above-identified application.

| X | No additional fee is required.

The fee has been calculated as shown below

CLAIMS AS AMENDED								
	(2) CLAIMS REMAINING AFTER AMENDMENT		(4) HIGHEST NO. PREVIOUSLY PAID FOR	(5) PRESENT EXTRA	RATE	ADDITIONAL FEE		
TOTAL CLAIMS	* 10	MINUS	**	0	x \$9 \$18	0		
INDEP. CLAIMS	* 6	MINUS	*** 6	0	x \$43 \$86	0		
Fee for Mu	0							
	0							

If the entry in Column 2 is less than the entry in Column 4, write "0" in Column 5.

If the "Highest Number Previously Paid For" IN THIS SPACE is less than 20, write "20" in this space. If the "Highest Number Previously Paid For" IN THIS SPACE is less than 3, write "3" in this space.

	Verified Statement claiming small entity status is enclosed, if not filed previously.
	A check in the amount of \$ is enclosed.
	Charge \$ to Deposit Account No. 06-1205. A duplicate copy of this sheet is enclosed
X	Any prior general authorization to charge an issue fee under 37 C.F.R. 1.18 to Deposit Account No. 06 1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 C.F.R. 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate copy of this paper is enclosed.
	A check in the amount of \$ to cover the fee for a month extension is enclosed.
	A check in the amount of \$ to cover the Information Disclosure Statement fee is enclosed.
X	Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.
	Respectfully submitted,
	Attorney for Applicants

Registration No. 35,345

FITZPATRICK, CELLA, HARPER & SCINTO 30 Rockefeller Plaza
New York, New York 10112-3800
Facsimile: (212) 218-2200

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## PATENT APPLICATION

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)	
••	:	Examiner: K. Ramsey
TOSHIKAZU ONISHI ET AL.	)	
	:	Group Art Unit: 2879
Application No.: 10/041,131	)	
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Filed: December 13, 2001	)	
	:	
For: METHOD FOR MANUFACTURING	)	
ELECTRON EMISSION ELEMENT,	:	
ELECTRON SOURCE, AND IMAGE	)	April 20, 2004
FORMING APPARATUS		

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## THIRD PRELIMINARY AMENDMENT

Sir:

Preliminary to continued examination, and after entry of the Preliminary

Amendment filed on December 1, 2003, and the Second Preliminary Amendment filed on

February 26, 2004, please further amend the above-identified application as follows, the claims changes being reflected in the listing that begins at page 2, and the Remarks beginning at page 6.